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APPLICANTS Hirofumi Fujioka, Tokyo, JAPAN; Kenichi Koyanagi, Tokyo, JAPAN; <i>Hirofumi Kitamura, Tokyo, JAPAN</i> ** CONTINUING DATA ***** <i>None & W.S.</i> ** FOREIGN APPLICATIONS ***** <i>& W.S.</i> JAPAN 194006/2002 07/02/2002				
IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 09/29/2003				
Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after met <i>allowance</i> Verified and <i>& W.S.</i> Acknowledged Examiner's Signature Initials		STATE OR COUNTRY JAPAN	SHEETS DRAWING 9	TOTAL CLAIMS 35 INDEPENDENT CLAIMS 3
ADDRESS 23373 SUGHRUE MION, PLLC 2100 PENNSYLVANIA AVENUE, N.W. SUITE 800 WASHINGTON, DC 20037				
TITLE METHOD FOR SEMICONDUCTOR DEVICE MANUFACTURING TO INCLUDE MULTISTAGE CHEMICAL VAPOR DEPOSITION OF MATERIAL OXIDE FILM				
FILING FEE RECEIVED 1320	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit	